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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP04/01315 02/09/2004

** FOREIGN APPLICATIONS *****

JAPAN 2003-031110 02/07/2003
 JAPAN 2003-129878 05/08/2003

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	31	65	9

ADDRESS

SUGHRUE MION, PLLC
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TITLE

Method for forming nickel silicide film, method for manufacturing semiconductor device, and method for etching nickel silicide

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